

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87270

Tsunehisa NAMIKI, et al.

Appln. No.: 10/530,357

Group Art Unit: 3742

Confirmation No.: 7770

Examiner: Quang T. VAN

Filed: September 23, 2005

For: METHOD OF FORMING A METAL OXIDE FILM AND MICROWAVE POWER
SOURCE DEVICE USED FOR THE ABOVE METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one (1) month, extending the time for responding to the Office Action of October 15, 2007 from January 15, 2008 to February 15, 2008.

The statutory fee of \$120.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,



Abraham J. Rosner
Registration No. 33,276

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: February 11, 2008